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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

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In re application of: Wu et al.

Attorney Docket No.:  
NOVLP091/NVLS-2889

Application No.: 10/820,525

Examiner: Maldonado, Julio J.

Filed: April 7, 2004

Group: 2823

Title: METHODS FOR PRODUCING LOW-K  
CDO FILMS WITH LOW RESIDUAL  
STRESS

Confirmation No: 8337

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CERTIFICATE OF EFS-WEB TRANSMISSION

I hereby certify that this correspondence is being transmitted electronically through EFS-WEB to the Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450 on July 30, 2008.

Signed: \_\_\_\_\_/Tara Hayden/  
Tara Hayden

**AMENDMENT D**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In response to the Office Action dated March 31, 2008 in the above-identified application, please amend the application as follows:

**Amendments to the Claims** are reflected in the listing of claims that begins on page 3 of this paper.

**Remarks/Arguments** are on page 8 of this paper.

A **Declaration under 37 CFR 1.132** of co-inventor Qingguo Wu, with attached Exhibits A and B, accompanies this paper.